



Appl. No. : 10/607,276
Applicant : Seokhyun LIM
Filed : June 27, 2003
TC/A.U. : 3752
Examiner : Patrick F. Brinson

Confirmation No. 4717

Docket No. : 1751-340
Cust. No. : 06449

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith copies of two publications that the Office may wish to consider in examination of the subject application. The publication is listed on the attached Form PTO-1449.

Please charge the \$180.00 cost thereof under 37 C.F.R. § 1.17(p) to deposit account no. 02-2135. An extra copy of this letter is attached.

Respectfully submitted,

By

Thomas E. McKiernan

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1751-340-ids

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Complete if Known	
				Application Number	10/607,276
				Filing Date	June 27, 2003
				First Named Inventor	Seokhyun LIM
				Group Art Unit	3752
				Examiner Name	Patrick F. Brinson
Sheet	1	of	1	Attorney Docket Number	1751-340
NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published			T ²
	A	LIM, S. & CHOI, H. 2003; "Optimal Shape Design of Pressure-driven Curved Micro Channels with Hydrophilic and Hydrophobic Walls"; Nanotech 2003, San Francisco, CA USA, Feb. 23-27, 2003 (vol. 1, pp. 170-173).			
	B	LIM, S. & CHOI, H. 2004; "Optimal Shape Design of a Pressure-driven Curved Micro Channel"; 42nd AIAA Aerospace and Sciences Meeting and Exhibit, Reno, NV USA, Jan. 5-8, 2004, AIAA-2004-624.			
Examiner Signature					Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.